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JC926 U.S. PTO

10-02-00

A

Patent Application Transmittal
(only for new nonprovisional applications under 37 C.F.R. 1.53(b))
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09/29/00

Date: September 29, 2000
Attorney Docket No.: 450100-02738

ASSISTANT COMMISSIONER FOR PATENTS
Box Patent Application
Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office
of an application for patent in the name(s) of:

Hitoshi HONDA, Masanori OMOTE, Hiroaki OGAWA, Hongchang PAO

entitled:
SPEECH PROCESSING APPARATUS, SPEECH PROCESSING METHOD, AND RECORDING MEDIUM
THEREFOR

The following are enclosed:

- ☒ Specification (69 pages)
- ☒ 31 Sheet(s) of Drawings
- ☒ 9 Claim(s) (including 3 independent claim(s))
- ☐ This application contains a multiple dependent claim

☒ Our check for \$ 690.00, calculated on the basis of the claims as
amended by any enclosed preliminary amendment as follows:

Basic Fee, \$690.00 (\$345.00)	\$ 690.00
Number of Claims in excess of 20 at \$18.00 (\$9.00) each:	-0-
Number of Independent Claims in excess of 3 at \$78.00 (\$39.00) each:	-0-
Multiple Dependent Claim Fee at \$260.00 (\$130.00)	-0-
Total Filing Fee	\$ 690.00
Assignment Recording Fee \$40.00	-0-

☒ Oath or Declaration and Power of Attorney
☒ New ☐ signed ☒ unsigned
☐ Copy from a prior application (37 C.F.R. 1.63(d))


☒ Certified copy of each of the following application(s) to substantiate
the claim(s) for priority made in the Declaration:

<u>Application No.</u>	<u>Filed</u>	<u>In</u>
11-277745	30 September 1999	Japan

Please charge any additional fees required for the filing of this
application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicants


William S. Frommer
Reg. No. 25,506

D. J.
#4 4-2301
Priority Papers
450100-02738

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09/29/00

"Express Mail" mailing label number EL588272971US

Date of Deposit September 29, 2000

I hereby certify that this paper or fee, and a patent application and accompanying papers, are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Assistant Commissioner for Patents, Washington, DC 20231.

Charles Jackson
(Typed or printed name of person mailing paper or fee)

Charles Jackson
(Signature of person mailing paper or fee)

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September 29, 2000

Assistant Commissioner for Patents
Washington, D.C. 20231

Re: U.S. Patent Application
Applicants: Hitoshi HONDA, Masanori OMOTE, Hiroaki OGAWA,
Hongchang PAO
Our Ref.: 450100-02738

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JEROME ROSENSTOCK
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SUSAN K. LEHNHARDT, PH.D.
RICHARD E. PARKE
Of Counsel

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

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Respectfully,



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Enclosures